



Patent
703538.4027

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/751,131 Confirmation No.: 1733
Applicant : Bedri Cetiner et al.
Filing Date : December 31, 2003
Title : RF MEMS FABRICATION ON A LAMINATED SUBSTRATE
Group Art Unit : 2821
Examiner : Phan, Tho Gia
Docket No. : 703538.4027
Customer No. : 34313

AMENDMENT AND RESPONSE

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment and Response is filed in response to an Office Action mailed on August 9, 2005. Please amend the subject application as follows.

The claims are provided in a claim listing beginning on page 2.

Remarks begin on page 5.

CERTIFICATE OF MAILING
(37 CFR §1.8a)

I have reasonable basis to expect that this paper (along with any referred to as being attached or enclosed) would be mailed from the United States Postal Service on the date indicated with sufficient postage as First Class Mail in an envelope addressed to Mail Stop AMENDMENT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Dated: February 9, 2006


Karen Johnson